



#15/D
8-26-00
Robert
PATENT *amdt*

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gurtej S. Sandhu

Serial No.: 09/023,146

Filed: February 12, 1998

For: TUNGSTEN SILICIDE (WSIx)
DEPOSITION PROCESS FOR
SEMICONDUCTOR MANUFACTURE

Examiner: T. Dang

Group Art Unit: 2823

Attorney Docket No.: 3369.1US
(91-365-RE)

CERTIFICATE OF MAILING

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AMENDMENT

Box Non Fee Amendment
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 12, 2000, the three-month shortened statutory period for response to which expires on August 12, 2000.

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AUG 24 2000
TECHNOLOGY CENTER 2800